

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10509616	
	Filing Date		2005-05-25	
	First Named Inventor	Migaku TAKAHASHI et al.		
	Art Unit	1792		
	Examiner Name	Alain L. BASHORE		
Attorney Docket Number		YIPO:002		

U.S. PATENTS						Remove
Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
	1					

If you wish to add additional U.S. Patent citation information please click the Add button.

Add

U.S. PATENT APPLICATION PUBLICATIONS						Remove
Examiner Initial*	Cite No	Publication Number	Kind Code ¹	Publication Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
	1					

If you wish to add additional U.S. Published Application citation information please click the Add button.

Add

FOREIGN PATENT DOCUMENTS							Remove	
Examiner Initial*	Cite No	Foreign Document Number ³	Country Code ² j	Kind Code ⁴	Publication Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear	T ⁵
	1							<input type="checkbox"/>

If you wish to add additional Foreign Patent Document citation information please click the Add button.

Add

NON-PATENT LITERATURE DOCUMENTS			Remove
Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.	T ⁵

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(Not for submission under 37 CFR 1.99)

Application Number	10509616
Filing Date	2005-05-25
First Named Inventor	Migaku TAKAHASHI et al.
Art Unit	1792
Examiner Name	Alain L. BASHORE
Attorney Docket Number	YIPO.002

1	Migaku TAKAHASHI et al., "The Ultra Clean Sputtering Process and High Density Magnetic Recording Media", IEEE Transactions on Magnetics, September 1997, pgs. 2938-2943, Volume 33, Number 5, IEEE	<input type="checkbox"/>
2	E.N. ABARRA et al., "Longitudinal magnetic recording media with thermal stabilization layers", Applied Physics Letters, October 16, 2000, pgs. 2581-2583, Volume 77, Number 16, American Institute of Physics	<input type="checkbox"/>
3	J.C.S. KOOLS, et al., "Effect of finite magnetic film thickness on Néel coupling in spin valves", Journal of Applied Physics, April 15, 1999, pgs. 4466-4468, Volume 85, Number 8, American Institute of Physics	<input type="checkbox"/>

If you wish to add additional non-patent literature document citation information please click the Add button

EXAMINER SIGNATURE

Examiner Signature	/Alain Bashore/ (10/27/2008)	Date Considered	
--------------------	------------------------------	-----------------	--

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through a citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ See Kind Codes of USPTO Patent Documents at www.USPTO.GOV or MPEP 901.04. ² Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). ³ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁴ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁵ Applicant is to place a check mark here if English language translation is attached.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /AB/